

Title (en)

VACUUM ELECTRON BEAM ARRANGEMENT AND METHOD FOR PRODUCING AN ELECTRODE THEREFOR

Title (de)

VAKUUM-ELEKTRONENSTRAHLANORDNUNG UND VERFAHREN ZUR HERSTELLUNG EINER ELEKTRODE DAFÜR

Title (fr)

DISPOSITIF À FAISCEAU D'ÉLECTRONS À VIDE ET PROCÉDÉ POUR RÉALISER UNE ÉLECTRODE DESTINÉE À CELUI-CI

Publication

**EP 2766916 A1 20140820 (DE)**

Application

**EP 12766910 A 20120827**

Priority

- DE 102011053949 A 20110927
- EP 2012066596 W 20120827

Abstract (en)

[origin: WO2013045183A1] In order to reduce the secondary electron emission in a vacuum electron beam arrangement, in particular a travelling wave tube (TWT), a surface structure with an open-pore surface layer (OS) and a method for producing such a surface structure are described.

IPC 8 full level

**H01J 23/027** (2006.01); **H01J 25/34** (2006.01)

CPC (source: EP)

**H01J 23/02** (2013.01); **H01J 23/027** (2013.01); **H01J 25/34** (2013.01)

Citation (search report)

See references of WO 2013045183A1

Designated contracting state (EPC)

AL AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MK MT NL NO PL PT RO RS SE SI SK SM TR

DOCDB simple family (publication)

**DE 102011053949 A1 20130328**; EP 2766916 A1 20140820; EP 2766916 B1 20181010; WO 2013045183 A1 20130404

DOCDB simple family (application)

**DE 102011053949 A 20110927**; EP 12766910 A 20120827; EP 2012066596 W 20120827